

AMENDMENT UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

|             |  |             |                     |
|-------------|--|-------------|---------------------|
| Applicant:  | Chen, <i>et al.</i>  | Docket No.: | QIM 2003 P 50508 US |
| Serial No.: | 10/622,607   | Art Unit:   | 2891                |
| Filed:      | July 18, 2003  | Examiner:   | Matthew W. Such     |
| Title:      | Method of Suppressing the Effect of Shining Spots Present at the Edge of a Wafer |             |                     |

Mail Stop AF  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. § 1.116

Dear Sir:

Applicants respectfully submit the following amendments and remarks in response to Examiner's Office Action dated September 24, 2007, which Action was made Final. Applicants respectfully request that these amendments and remarks be entered in pursuant to the provisions of 37 C.F.R. § 1.116, and respectfully request reconsideration of the claims.